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**RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE REQUESTED
EXAMINING GROUP 2813**

PATENT

Customer No. 22,852

Attorney Docket No. **08244.0032**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
)	
Sung-Chan PARK et al.)	Group Art Unit: 2813
)	
Application No.: 09/998,303)	Examiner: Nguyen, Thanh T.
)	
Filed: December 3, 2001)	
)	
For: METHOD FOR FORMING)	Confirmation No.: 4821
CONTACT HOLE AND SPACER)	
OF SEMICONDUCTOR DEVICE)	

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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

REQUEST FOR RECONSIDERATION AFTER FINAL

In reply to the Final Office Action mailed October 11, 2005, the period for response extending through January 11, 2006, Applicants request reexamination and reconsideration of the above-identified application based on the following remarks.

Remarks begin on page 2 of this paper.